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PATENT APPLICATION

Attorney Docket No.: 108057

AMENDMENT TRANSMITTAL

In re the Application of

Kiyoichi SUWA

Group Art Unit: 2818

Application No.: 09/729,339

Examiner: Q. Hoang

Filed: December 5, 2000

For: MASK, EXPOSURE METHOD, LINE WIDTH MEASURING METHOD, AND METHOD FOR
MANUFACTURING SEMICONDUCTOR DEVICES

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

- ☐ Entitlement to small entity status is hereby asserted.
☐ Small entity status of this application has been established.

The filing fee has been calculated as shown below:

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MAY 30 2003
TECHNOLOGY CENTER 2800

	(Column 1)	(Column 2)	(Column 3)	SMALL ENTITY			OTHER THAN A SMALL ENTITY	
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADD'L FEE	OR	RATE	ADD'L FEE
TOTAL CLAIMS	*21 MINUS	**20	=1	x 9	\$		x 18	\$ 18
INDEP CLAIMS	*3 MINUS	***3	=0	x 42	\$		x 84	\$
				+ 140	\$	OR	+280	\$
					\$			\$ 18
<input type="checkbox"/> FIRST PRESENTATION OF MULTIPLE DEP. CLAIM								

- * If the entry in Column 1 is less than the entry in Column 2, write "0" in Column 3.
** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.
*** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.

The "Highest Number Previously Paid For" in this space (Total or Independent) is the highest number found from the equivalent box in Column 1 of a prior Amendment or the number of claims originally filed.

- ☒ Check No. 142487 in the amount of \$18.00 is attached. The Commissioner is hereby authorized to charge any other fees that may be required to complete this filing, or to credit any overpayment, to Deposit Account No. 15-0461. Two duplicate copies of this sheet are attached.

Respectfully submitted,

Mario A. Costantino
Registration No. 33,565

MAC/ccs

Date: May 27, 2003



#18/Amdt B
6.10.03
C. Moore
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Kiyoichi SUWA

Group Art Unit: 2818

Application No.: 09/729,339

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Docket No.: 108057

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METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICES

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the November 27, 2002 Office Action, the shortened statutory period for
reply being extended by the attached Petition for Extension of Time, please consider the
following:

Amendments to the Claims are reflected in the listing of claims; and

Remarks.

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